

Electronic Filing System (EFS) Data  
Electronic Patent Application Submission  
USPTO Use Only

EFS ID: 69634

Application ID: 10711691



Title of Invention:

APPARATUS AND METHOD FOR  
MANIPULATING SAMPLE  
TEMPERATURE FOR FOCUSED  
ION BEAM PROCESSING

First Named Inventor: Chad Rue

Domestic/Foreign Application: Domestic Application

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U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE  
FEE RECORD SHEET

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